



BOX AF
RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINER GROUP 2851

03560.002758

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

RYUICHI EBINUMA, ET AL.

Application No.: 09/817,018

Filed: March 27, 2001

For: SUPPORTING STRUCTURE OF OPTICAL
ELEMENT, EXPOSURE APPARATUS
HAVING THE SAME, AND MANUFACTUR-
ING METHOD OF SEMICONDUCTOR DEVICE:

)
: Examiner: Hung Nguyen

)
: Group Art Unit: 2851

)
: September 22, 2003

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Mail Stop AF
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the Official Action dated June 23, 2003, please amend the
above-identified application as follows.

09/24/2003 BABRAHA1 00000072 09817018

01 FC:1201

252.00 OP